

L Number	Hits	Search Text	DB	Time stamp
-	55669	aluminum adj oxide	USPAT; US-PGPUB	2003/12/10 11:51
-	149060	alumina\$1	USPAT; US-PGPUB	2003/12/10 11:51
-	10345	"Al.sub.2O.sub.3"	USPAT; US-PGPUB	2003/12/10 11:52
-	1000	Al2O3	USPAT; US-PGPUB	2003/12/10 11:52
-	359	"AlO.sub.3"	USPAT; US-PGPUB	2003/12/10 11:52
-	8	AlO3	USPAT; US-PGPUB	2003/12/10 11:52
-	1336	AlO	USPAT; US-PGPUB	2003/12/10 11:53
-	1420427	(atomic adj layer) near\$3 deposit\$3	USPAT; US-PGPUB	2003/12/10 11:53
-	1038	atomic adj layer adj deposit\$3	USPAT; US-PGPUB	2003/12/10 11:54
-	1652	ALD	USPAT; US-PGPUB	2003/12/10 11:54
-	256	((aluminum adj oxide) alumina\$1 "Al.sub.2O.sub.3" Al2O3 "AlO.sub.3" AlO3 AlO) same ((atomic adj layer adj deposit\$3) ALD)	USPAT; US-PGPUB	2003/12/10 12:25
-	1036928	layer	USPAT; US-PGPUB	2003/12/10 12:23
-	2223373	material	USPAT; US-PGPUB	2003/12/10 12:23
-	650738	film	USPAT; US-PGPUB	2003/12/10 12:23
-	44933	barrier adj (layer material film)	USPAT; US-PGPUB	2003/12/10 12:25
-	2221	((aluminum adj oxide) alumina\$1 "Al.sub.2O.sub.3" Al2O3 "AlO.sub.3" AlO3 AlO) same (barrier adj (layer material film))	USPAT; US-PGPUB	2003/12/10 12:26
-	252160	capacitor	USPAT; US-PGPUB	2003/12/10 12:26
-	347	capacitor and (((aluminum adj oxide) alumina\$1 "Al.sub.2O.sub.3" Al2O3 "AlO.sub.3" AlO3 AlO) same (barrier adj (layer material film)))	USPAT; US-PGPUB	2003/12/10 12:26